

SADH  
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11-14.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re application of: Ryoichi OHKURA et al.

Serial No.: ~~Not Yet Assigned~~ 09/871250

Filed: June 1, 2001

For: SUBSTRATE CLEANING SYSTEM

PRELIMINARY AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

June 1, 2001

Sir:

Prior to the calculation of the filing fees of the above application, please amend the application as follows:

IN THE CLAIMS:

Please amend claims 4, 6, 8-10 and 12 as follows:

A1  
Sub 47  
4. [(Amended)] The substrate cleaning system according to Claim 1 or 2, wherein the carry-in section Aa and the carry-out section Ab have substrate holding sections 60 for holding carriers in which a plurality of substrates are stocked in a horizontal state with a given alignment pitch in a vertical direction, and an elevation positioning unit 61 for positioning the substrates to be carried in or out from the carriers 56.

A2  
Sub 47  
6. [(Amended)] The substrate cleaning system according to Claim 1 or 2, wherein the transport robots 70 in the robot booth B are formed of a twin arm robot each provided with a pair